



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1734

Examiner: Yewebdar T. Tadesse

In Re PATENT APPLICATION Of:

Applicant(s): Toshikazu YAMAUCHI

Serial No.: 10/670,725

Filed: September 26, 2003

For: PHOTORESIST APPLYING DEVICE  
AND APPLYING METHOD THEREFOR

Atty. Dkt.: OKI 378

**PETITION FOR  
TWO MONTH  
EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the period for replying to the Examiner's Action dated October 28, 2004, be extended for two months under the provisions of 37 C.F.R. 1.136(a).

The applicable extension fee of \$450.00 pursuant to 37 C.F.R. 1.17(a)(2) is submitted herewith.

Should this remittance be accidentally missing, or should any additional fees be required, however, the Commissioner is hereby authorized to charge such fees to our Deposit Account No. 18-0002 and advise us accordingly. A duplicate copy of this paper is enclosed.

03/16/2005 HBEYEN1 00000023 10670725

01 FC:1252

450.00 0P

March 16, 2005

Date

FEE ENCLOSED: \$450.00  
Please charge any further  
fee to our Deposit Account  
No. 18-0002

RHB:vm

Respectfully submitted,

Robert H. Berdo, Jr.  
Registration No. 38,075  
RABIN & BERDO, PC  
Customer No. 23995  
Telephone: 202-371-8976  
Facsimile: 202-408-0924